| Electronic Acknowledgement Receipt   |  |  |
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| EFS ID:                              | 1523225  |  |
| Application Number:                  | 10750983   |  |
| International Application Number:    |  |  |
| Confirmation Number:                 | 5470   |  |
| Title of Invention:                  | Semiconductor device having silicide layers and method of fabricating the same |  |
| First Named Inventor/Applicant Name: | Jeong-Min Choi   |  |
| Customer Number:                     | 20575  |  |
| Filer:                               | Hosoon Lee/Stormi Davis  |  |
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| Attorney Docket Number:              | 4591-366   |  |
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| Time Stamp:                          | 15:38:38   |  |
| Application Type:                    | Utility  |  |

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| Submitted with Payment | no |
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## File Listing:

| Document<br>Number | Document Description | File Name     | File Size(Bytes) | Multi<br>Part /.zip | Pages<br>(if appl.) |
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| 1                  |                      | 4591-366e.pdf | 1369378          | yes                 | 25                  |

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|           | Document Description                                | Start | End |  |
|           | Miscellaneous Incoming Letter                       | 1     | 1   |  |
|           | Amendment - After Non-Final Rejection               | 2     | 6   |  |
|           | Applicant Arguments/Remarks Made in an Amendment    | 7     | 8   |  |
|           | Translation of Foreign Priority Documents           | 9     | 25  |  |
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#### New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

#### New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.